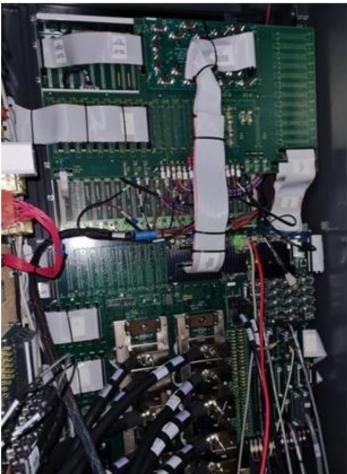


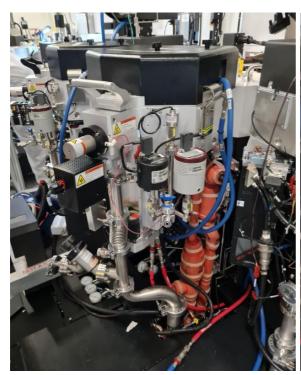
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Centura DCVD	
Manufacturer	Applied Materials
Model	Centura CVD
Description	Plasma, CVD
Other information	
Year of manufacture	2008
Serial number	21279
Site size	8
Condition	good
Number of Units	
Product description	Software Version B5226
Mainframe version:	Centura 1 5200 DCVD
Type of chuck:	E-Chucks in positions C+D, ceramic heaters in positions A+B
Process:	Chamber A+B Teos BPSG, chambers C+D Etch PE SILANE DXZ DARC
Chiller:	Neslab Steelhead 0 (original)
	208 VAC, 4 Wire, 240A load current, 50Hz



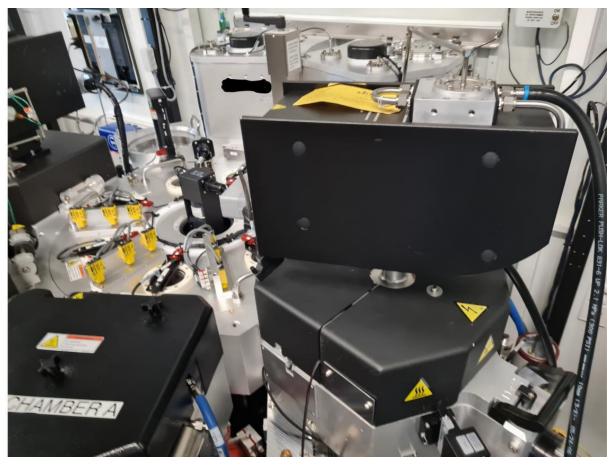


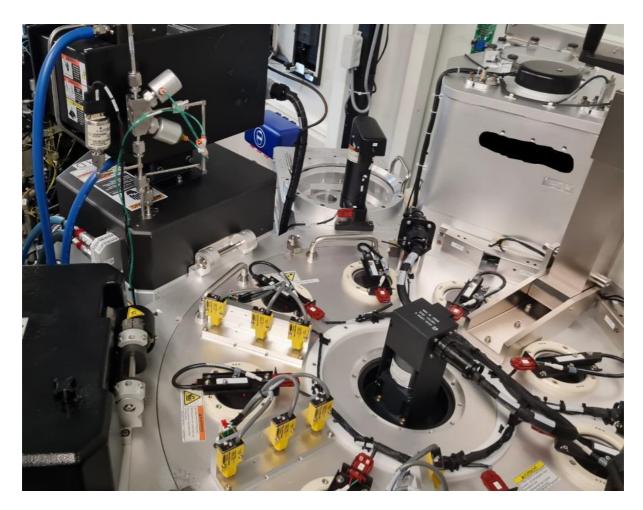
















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All Equipment is offered subject to prior sale. This item will be quoted based upon specific terms and configuration required. Interested parties may contact PTW Asia Pte Ltd at: ask@ptwsingapore.com

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